

## UNITED STATES DEPARTMENT OF COMMERCE United States Pat int and Trademark Office

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APPLICATION NO. FILING DATE FIRST NAMED INVENTOR ATTORNEY DOCKET NO. 09/534,207 055902 03/24/00 KASHIWAYA **EXAMINER** IM52/0801 SUGHRUE MION ZINN MACPEAK & SEAS PLLC APEUNITO PAPER NUMBER 2100 PENSYLVANIA AVENUE N W WASHINGTON DC 20037-3202 DATE MARLED:

08/01/01

Please find below and/or attached an Office communication concerning this application or proceeding.

**Commissioner of Patents and Trademarks** 

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•		Applicati	ion No.	Applicant(s)			
نجر ا	and and	09/534,2	07	SHIWAYA ET AL.			
•	Offic Action Summary	Examine		Art Unit	<del></del>		
		DuyVu n		1765			
	The MAILING DATE of this commun						
I ME I - Exter after - If the - If NO - Failu - Any r	ORTENED STATUTORY PERIOD F MAILING DATE OF THIS COMMUNI nations of time may be available under the provisions SIX (6) MONTHS from the mailing date of this comm period for reply specified above is less than thirty (3) period for reply is specified above, the maximum state to reply within the set or extended period for reply eply received by the Office later than three months a d patent term adjustment. See 37 CFR 1.704(b).	ICATION. of 37 CFR 1.136(a). In no ev nunication. 0) days, a reply within the stat attutory period will apply and w will by statute cause the app	ent, however, may a reply be til lutory minimum of thirty (30) day iill expire SIX (6) MONTHS from	mely filed  ys will be considered timely.  the mailing date of this communical	tion.		
1)	Responsive to communication(s) fil	ed on					
2a)□			non-final				
3)		This action is FINAL. 2b) This action is non-final.  Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
	closed in accordance with the pract	ice under <i>Ex parte Q</i>	uayle, 1935 C.D. 11,	153 O.G. 213.	s is		
·	on of Claims						
İ	Claim(s) 1-4 is/are pending in the ap	-					
	4a) Of the above claim(s) is/ar	e withdrawn from co	nsideration.				
5) Claim(s) is/are allowed.							
6)⊠ Claim(s) <u>1-4</u> is/are rejected.							
ľ	7) Claim(s) is/are objected to.						
	Claim(s) are subject to restrict	tion and/or election re	equirement.		no.		
Application	•				5		
9) The specification is objected to by the Examiner.					,		
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.					E		
11)□⊤	Applicant may not request that any obje				ſ		
'')'	he proposed drawing correction filed If approved, corrected drawings are requ			yed by the Examiner.	1		
12)□ ⊺	he oath or declaration is objected to		ice action.		(		
	nder 35 U.S.C. §§ 119 and 120	by the Examiner.					
	Acknowledgment is made of a claim f	for foreign priority und	ter 35     S.C. & 110(5)	L(d) or (f)	•		
	All b) Some * c) None of:	er rereign priontly unt	101 00 0.0.0. g 110(a)	r-(u) or (i).			
1. Certified copies of the priority documents have been received.							
2. Certified copies of the priority documents have been received in Application No							
3	Copies of the certified copies of						
* Se	application from the Internate the attached detailed Office action	tional Bureau (PCT F	Rule 17.2(a)).	_			
<b>14)</b> □ Ac	knowledgment is made of a claim for	domestic priority und	der 35 U.S.C. § 119(e	) (to a provisional applicat	ion).		
a)	☐ The translation of the foreign lang knowledgment is made of a claim for	uage provisional app	olication has been rece	eived.			
Attachment(s		,,					
2) Notice	of References Cited (PTO-892) of Draftsperson's Patent Drawing Review (PTO tion Disclosure Statement(s) (PTO-1449) Pap	D-948)		(PTO-413) Paper No(s) atent Application (PTO-152)			

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## **DETAILED ACTION**

## Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1-4 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamazaki (US 4,816,113).

Yamazaki teaches a method for forming a carbon layer by vapor phase deposition comprising steps of: cleaning the apparatus by removing undesirable products such as carbon deposition from the inside of the chamber (in between the carbon deposition or this would means the cleaning is performed before another deposition); the chamber is then evacuated to  $1\times10^{-6}$ Torr or a higher vacuum condition; starting a film deposition process of the carbon (col. 5, line 41-col. 6, line 2; col. 3, line 41-col. 4, line 2). Unlike claimed invention, Yamazaki doesn't describe adjusting the content of particles having a particle size of 0.5 um or more to 1000 particles/ft<sup>3</sup>/min or less (such as 500 or 100 particles/ft<sup>3</sup>/min). However, his steps of cleaning and evacuation the chamber to a high vacuum condition would reduce any undesirable products including particles having a particle size of 0.5 um or more to 1000 particles/ft<sup>3</sup>/min or less (such as claimed 500 or 100 particles/ft<sup>3</sup>/min).

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Referring to claim 3, the application of deposition of carbon layer as a protective layer on a thermal head performing thermal recording is known to one skill in the art as described in the background of the specification.

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to DuyVu n Deo whose telephone number is 703-305-0515.

DVD July 30, 2001

> BENJAMIN L. UTECH SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 1700